



Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Doctor Number (Optional)

T5MC-02-1329

Anderson House

10/696,642

Appleton Haan-Liang Tseng et al.

Filing Date 10/29/03 Group A1 Unit

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

| | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|--|-----------------|------|---------|-------|----------|-------------|----|
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OTHER DOCUMENTS (including Author, Title, Date, Portion and Pages, Etc.)

(10) - US Patent App. Publication US 2002/0071744 A1 to Bachrach, Pub date 6/13/02, "Compact Apparatus and Method for Storing and Loading Semiconductor Wafer Carriers", US Class 414/217, Filed 1/10/02.

(10) - US Patent App. Publication US 2002/0164242 A1 to Wehrung et al, Pub date 11/7/02, "Control System for Transfer and Buffering", US Class 414/935, Filed 1/24/02.

EXAMINEE

HAROLD JOYCE

DATE CONSIDERED

7-25-04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.